

**Certification under 37 CFR 1.8(a)**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to The Commissioner for Patents, Washington, D.C. 20231 on February 17, 2003.

Vangelis Economou  
Name

  
Signature

DOCKET: CU-2636

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

APPLICANT: Sang Ick LEE et al )  
SERIAL NO: 09/994,284 ) Group Art Unit: 2823  
FILING DATE: November 26, 2001 ) Examiner:  
TITLE: METHOD OF FORMING METAL GATE IN ) Pham, Thanh V  
SEMICONDUCTOR DEVICE )

The Commissioner for Patents  
Washington, D.C. 20231

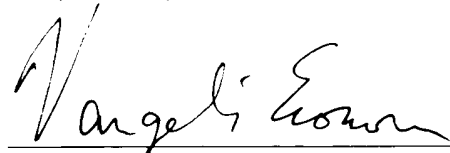
**REQUEST FOR ONE MONTH EXTENSION**

Dear Sir:

With reference to the Final Office Action dated October 15, 2002, applicant respectfully requests a one month extension of the term for response, from the present term of January 15, 2003 up to a new term of February 15, 2003.

Enclosed is check in the amount of \$110 to cover the fee for this one month extension. Should any additional fee be deemed necessary, the Commissioner is authorized to charge our Deposit Account No. 12-0400.

Respectfully submitted,

  
Attorney for Applicant

February 17, 2003  
Date

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